

OK TO ENTER: /MS/

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07/13/2010

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Tois et al.
App. No	:	10/678,766
Filed	:	October 2, 2003
For	:	METHOD OF GROWING OXIDE THIN FILMS
Examiner	:	Matthew J. Song
Art Unit	:	1792
Conf No.	:	1629

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action electronically sent on April 1, 2010. Consideration of the following remarks is respectfully requested.

The Claims are reflected in the **Listing of Claims** which begins on page 2 of this paper.

Summary of Interview begins on page 7 of this paper.

Remarks begin on page 8 of this paper.